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SERIAL NUMBER 10/071,127	FILING DATE 02/08/2002 RULE	CLASS 438	GROUP ART UNIT 2822	ATTORNEY DOCKET NO. 2013P015
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APPLICANTS

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** CONTINUING DATA ***** *JMJ*

None

** FOREIGN APPLICATIONS ***** *JMJ*

REPUBLIC OF KOREA 01-62350 10/10/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY **

** 04/02/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Amie M. Thomas</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 10	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 1
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ADDRESS

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90025-1030

TITLE

Method for fabricating power semiconductor device having trench gate structure

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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